## RESPONSE UNDER 37 CFR §1.116 EXPEDITED PROCEDURE TECHNOLOGY CENTER ART UNIT 1794

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Akira SAKURAI et al. Group Art Unit: 1794

Application No.: 10/533,546 Examiner: M. JACKSON

Filed: May 2, 2005 Docket No.: 123653

For: A METHOD FOR FORMING A THIN FILM OF SILVER MIRROR AND A METHOD FOR FORMING A COATED FILM CONTAINING SAID THIN FILM OF SILVER

MIRROR OK TO ENTER: /MJ/

## REQUEST FOR RECONSIDERATION AFTER FINAL REJECTION

Commissioner for Patents P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In reply to the October 29, 2008 Office Action, please consider the following:

Remarks.